

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/724,892	CHANG ET AL.	
Examiner		Art Unit		Page 1 of 1
David Y. Chung		2871		

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,504,585	01-2003	Ohkawara et al.	349/38
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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